



PLASUS EMICON MC Series

Data Sheet

| | EMICON I MC/2 MC | EMICON 3 MC – 8 MC | | | |
|---|--|----------------------------------|--|--|--|
| Number of spectrometer channels | I - 2 | 3 - 8 | | | |
| Spectral range | 200 - 1100 nm (totally covered by each spectrometer) | | | | |
| Number of wavelength channels (monitor tracks) | unlimited (selected by software without hardware modification) | | | | |
| Analysis of monitor tracks | single, combined (+,-, /,*), ratio, average, integral | | | | |
| Spectral resolution | I.5 nm FWHM | | | | |
| Minimum time resolution | approx. 15 ms | | | | |
| Exposure time | I ms – 65 sec | | | | |
| Detector | CCD array with 16 Bit A/D converter | | | | |
| Optical fiber connector | SMA 905 | | | | |
| Analog outputs [*] | 4 x ±10 volts | 8 x ±10 volts | | | |
| Digital outputs [*] | 2 x TTL | 4 x TTL | | | |
| Digital inputs [*] | 2 x TTL | 4 x TTL | | | |
| Electrical connector [*] | BNC | | | | |
| Remote control interfaces (optional) | LAN API, Profibus, Digital inputs | | | | |
| PC connections | I x USB | | | | |
| Power supply | 5 VDC 2A | 5 VDC 5A | | | |
| Housing | I 0" desktop box (3U, 42HP) | 19" rack mount box (3U, 84HP) | | | |
| Dimensions [mm] | 240 x 135 x 320 | 345 x 135 x 320 | | | |
| Weight [kg] | 2.5 | 3.5 – 4.5 | | | |
| Software | EMICON multi-channel software | | | | |
| System requirements | PC Pentium 4, 2.0GHz, Windows [®] 7/8/10 | | | | |
| Typical applications | PECVD, (reactive) sputtering, etching, HIPIMS, ATM plasmas | | | | |
| Field of application | QA/QC, process control/development, endpoint detection, fault detection, plasma analysis | | | | |

* Other options are available on request

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PLASUS EMICON SA Series

Data Sheet

| | EMICON I SA – 8 SA | | |
|---|--|--|--|
| Number of spectrometer channels | I - 8 | | |
| Spectral range | 200 - 1100 nm (totally covered by each spectrometer) | | |
| Number of wavelength channels (monitor tracks) | unlimited (selected by software without hardware modification) | | |
| Analysis of monitor tracks | single, combined (+,-, /,*), ratio, average, integral | | |
| Spectral resolution | I.5 nm FWHM | | |
| Minimum time resolution | l ms | | |
| Detector | CCD array with 16 Bit A/D converter | | |
| Optical fiber connector | SMA 905 | | |
| Analog inputs | 2 (4, 8) x 0-10 volts (iCoupler) | | |
| Analog outputs | 4 (8) \times 0-10 volts (iCoupler) | | |
| Digital outputs | 8 (16) x TTL / 24V (Opto-Coupler) | | |
| Digital inputs | 8 (16) x TTL / 24V (Opto-Coupler) | | |
| Remote control interfaces | LAN, digital inputs, (Profibus) | | |
| Processor unit | Integrated MPU with EMCON SA operation system | | |
| Display | 5,7" color touch panel (resistive) | | |
| Power supply | 5 VDC 4A | | |
| Housing | 19" rack mount box (4U, 84HP) | | |
| Dimensions [mm] | $480(w) \times 190(h) \times 420(d)$ | | |
| Weight [kg] | 3.5 | | |
| Remote administration | EMICON SA Manager software on Windows [®] 7/8/10 | | |
| Typical applications | PECVD, (reactive) sputtering, etching, HIPIMS, ATM plasmas | | |
| Field of application | process control, QA/QC, endpoint detection, fault detection in production lines | | |

Other options are available on request





PLASUS EMICON HR Series

Data Sheet

| | EMICON HR UV-VIS-NIR | EMICON HR | EMICON HR VIS | EMICON HR NIR | | |
|--|--|--------------|------------------|------------------|--|--|
| Spectral range | 200 - 860 nm | 200 - 440 nm | 440 – 670 nm | 670 – 860 nm | | |
| Number of spectrometer channels | I | | | | | |
| Number of wavelength channels (monitor tracks) | unlimited (selected by software without hardware modification) | | | | | |
| Analysis of monitor tracks | single, combined (+,-, /,*), ratio, average, integral | | | | | |
| Spectral resolution | 0.15 nm FWHM | | | | | |
| Time resolution | approx. 15 ms | | | | | |
| Exposure time | I ms – 65 sec | | | | | |
| A/D converter | l6 Bit | | | | | |
| Optical fiber connector | SMA 905 | | | | | |
| Analog outputs* | 4 x ±10 volts | | | | | |
| Digital outputs [*] | 2 x TTL | | | | | |
| Digital inputs [*] | 2 x TTL | | | | | |
| Electrical connector* | BNC | | | | | |
| Remote control interfaces (optional) | LAN API, Profibus, Digital inputs | | | | | |
| PC connections | I x USB | | | | | |
| Power supply | 5 VDC 5A | | | | | |
| Housing | 10" desktop box (3U, 42HP) | | | | | |
| Dimensions [mm] | 240 × 135 × 320 | | | | | |
| Weight [kg] | 3.5 | | | | | |
| Software | EMICON software | | | | | |
| System requirements | PC Pentium 4, 2.0GHz, Windows [®] 7/8/10 | | | | | |
| Typical applications | PECVD, (reactive) sputtering, etching, HIPIMS, ATM plasmas | | | | | |
| Field of application | R&D, plasma analysis, process development/optimization/control, endpoint detection, QA/QC | | | | | |

* Other options are available on request